| LMC:eiv 07/13/09 | 23-65037-01 | 13664-B |
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## INFORMATION DISCLOSURE STATEMENT **BY APPLICANT**

| Attorney Docket Number | 23-65037-01           |  |
|------------------------|-----------------------|--|
| Application Number     | 10/726,744            |  |
| Filing Date            | December 2, 2003      |  |
| First Named Inventor   | Larry C. Olsen        |  |
| Art Unit               | 1795                  |  |
| Examiner Name          | Jeffrey Thomas Barton |  |

## **U.S. PATENT DOCUMENTS**

Copies of U.S. Patent documents do not need to be provided, unless requested by the Patent and Trademark Office. For patents, provide the patent

| Examiner's<br>Initials* | Cite No.<br>(optional) | Number  | Date         |          | Name of Applicant or Patentee |                               |  |
|-------------------------|------------------------|---|--------------|----------|-------------------------------|-------------------------------|--|
|                         |                        | FO  | REIGN PATENT | DOCUM    | ENTS                          |                               |  |
| Examiner's<br>Initials* | Cite No.<br>(optional) | Country   | Number       | Da       | te                            | Name of Applicant or Patentee |  |
| Examiner's              | Cite No.               |   | OTH          | IFP DOCI | IMENT                         | 2                             |  |
| Initials*               | (optional)             | OTHER DOCUMENTS  Nurnus, J. et al., "Structural and Thermoelectric Properties of Bi <sub>2</sub> Te <sub>3</sub> Based Layered Structures," <i>Proc. 19th Int. Conf. Thermoelectrics</i> , Cardiff, U.K., pp. 236-240 (August 25 29, 2000). |              |          |                               |                               |  |
|                         |                        |   |              |          | k Office                      | in U.S. Patent Application    |  |
|                         |                        | Office action from  |              |          | rk Office                     | in U.S. Patent Application    |  |

| EXAMINER   | DATE        |
|------------|-------------|
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<sup>\*</sup> Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.